

Roundtable on Empirical Methods in Intellectual Property

Thursday-Friday, June 18-19, 2020

Location: Cardozo Law School, New York, NY

We are pleased to announce the seventh annual Roundtable on Empirical Methods in Intellectual Property. Northwestern Pritzker School of Law, Cardozo Law School, and the United States Patent & Trademark Office are negotiating an agreement to co-host the event. The roundtable will take place at Cardozo Law School in New York City on June 18-19, 2020.

The roundtable is intended to give scholars engaging in empirical and experimental studies of IP a chance to receive feedback on their work at an early stage in their research. Accordingly, the roundtable will be limited to a small cohort of scholars discussing projects that are still in their developmental stages. Projects that will have substantially begun data collection by the time of the roundtable are inappropriate. Pilot data collection is, however, appropriate.

The roundtable will be organized around a modest number of projects. Each project presenter will be expected to circulate a description of the project of no more than 10 pages by June 5, 2020. Each project will be assigned to an expert commenter and will be allotted 45 minutes of discussion by the attendees.

We welcome applications from scholars in the social sciences and law. Domestic travel and lodging support for presenters will be provided.

Applications are due by April 3, 2020. We will notify applicants by April 24, 2020.

To apply to present at the workshop, please email CardozoIPIL@yu.edu with the following information:

Name

Institutional Affiliation

Title of Project

Description of Project (<750 words) including the issues to be addressed and the empirical methods to be employed.

Acknowledgement that the project will not have reached data collection by the time of the workshop.

Conference Organizers:

Christopher Buccafusco, Cardozo Law School

David Schwartz, Northwestern Pritzker School of Law

Andrew Toole, Acting Chief Economist USPTO